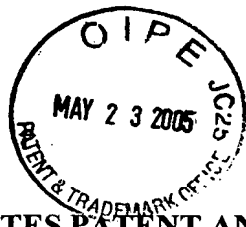


Docket No.: 240416US0DIV/hyc



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Masakazu KANECHIKA, et al.

SERIAL NUMBER: 10/618,085

GROUP: 2813

FILED: July 14, 2003

EXAMINER: Tuan H. NGUYEN

FOR: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND
SEMICONDUCTOR DEVICE

**REQUEST FOR PRIORITY ACKNOWLEDGMENT UNDER 35 U.S.C. 119
AND THE INTERNATIONAL CONVENTION**

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SIR:

In the matter of the above-identified application for patent, notice is hereby given that
the Applicant(s) claim as priority:

<u>Country</u>	<u>Application No.</u>	<u>Month/Day/Year</u>
Japan	10-313976	October 16, 1998
Japan	11-092855	March 31, 1999
Japan	11-172024	June 18, 1999
Japan	11-242883	August 30, 1999


A Certified copy of the corresponding Convention Application was filed in Serial
Number 09/420,524, filed October 18, 1999, of which this application is a Divisional.

Respectfully submitted,

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